



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 2779
Hiromi OGASAWARA et al. : Docket No. 2003_0912A
Serial No. 10/616,996 : Group Art Unit 2813
Filed July 11, 2003 : Examiner Jennifer M. Dolan

METHOD OF MANUFACTURING A
SEMICONDUCTOR
ELEMENT

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Responsive to the Office Action dated August 11, 2004, the period for response to which having been extended by three-months to February 11, 2005, please amend the above-identified application as follows.